



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al.

Docket No. : CIL-10972

Serial No. : 10/086,614

Art Unit : 1762

Filed : March 1, 2002

Examiner : B. Pianalto

For : Ion-Assisted Deposition Techniques For
The Planarization Of Topological Defects

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

I hereby certify that the *attached* correspondence comprising:

1. Amendment in Response to Notice of Non-Compliant Amendment (6 pages);
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P. O. Box 1450
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on November 29, 2004

John P. Wooldridge
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John P. Wooldridge
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AMENDMENT IN RESPONSE TO NOTICE OF NON-COMPLIANT
AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Non-Compliant Amendment mailed October 29,
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